

IFW



PATENT
Customer No. 22,852
Attorney Docket No. 04329.3128

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Katsuhiko HIEDA)	Group Art Unit: 2812
)	
Serial No.: 10/650,852)	Examiner: Kennedy, Jennifer M.
)	
Filed: August 29, 2003)	
)	
For: SEMICONDUCTOR DEVICE AND)	
METHOD OF MANUFACTURING)	
THE SAME)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In the Office Action dated September 30, 2004, the period for response to which extends through October 30, 2004, the Examiner required restriction under 35 U.S.C.

§ 121 between the following groups:

Group I, claims 1-6, characterized by the Examiner as drawn to a semiconductor device; and

Group II, claims 7-12, characterized by the Examiner as drawn to a method of making a semiconductor device.

Applicant provisionally elects to prosecute Group I, including claims 1-6, without traverse.


Applicant has also amended claims 1 and 4 and added new claims 13 and 14 by a Preliminary Amendment filed concurrently herewith.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: October 29, 2004

By: 
Qingyu Yin*

*With limited recognition under 37 C.F.R. § 10.9(b)